

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: Sun-Uk Kim, et al.	Art Unit	: 1791
Serial No.	: 10/560,023	Examiner	: Erin Lynn Snelting
Filed	: December 8, 2005	Conf. No.	: 1005
Title	: Method For Fabricating A Porous Silica Sphere		

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

NOTICE OF APPEAL FROM THE EXAMINER TO THE  
BOARD OF PATENT APPEALS AND INTERFERENCES

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the last decision of the examiner.

The notice of appeal fee in the amount of \$540.00 is being paid concurrently herewith on the Electronic Filing System (EFS) by way of Deposit Account authorization together with the Petition for Extension of Time fee in the amount of \$980.00. The first-months extension fee was previously paid on March 15, 2010. Please apply any other charges to Deposit Account No. 50-4189, referencing Attorney Docket No. 76303-003US1.

Respectfully submitted,

Date: 5-13-10

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